



2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Chih-Ming Ke

Group Art Unit: 1765

Serial No.: 10/ 047,266

Examiner: Kin Chan Chen

Filed: Jan. 14, 2002

In Response to Office Action
Dated: May 23, 2003

For: Reducing Photoresist Shrinkage Via Plasma Treatment

Attorney Docket No.: 67,200-641

3

6/18/03

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Kathy Dixon

Date: June 6, 2003

RECEIVED
JUN 17 2003
TC 1700

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed May 23, 2003 of a restriction requirement imposed by the Examiner, the Applicants hereby elect with traverse the prosecution of Group I, method claims (claims 1-15).

Respectfully submitted,

Tung & Associates

Randy W. Tung
Reg. No. 31,311
Telephone: (248) 540-4040

RECEIVED
JUN 12 2003
TECHNOLOGY CENTER 2806